

FORM PTO-1449 (modified)
To: U.S. Department of Commerce
(PW FORM PAT-1449)
Patent and Trademark Office

Atty.
Dkt. No.

M#

Client Ref.

305246

P-0199.011-US

**INFORMATION DISCLOSURE STATEMENT
BY APPLICANT**

Applicant: Theodorus H.J. BISSCHOPS

Appln. No.: ~~09/910,616~~ 10/637,635

Filing Date: August 11, 2003

Date: August 11, 2003

Page

1

of

1

Examiner: R. FULLER

Group Art Unit: 2851

U.S. PATENT DOCUMENTS

Examiner's Initials*		Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
PT	AR	4,484,074	11/1984	Eder			
PT	BR	4,916,322	04/1990	Glavish et al.			
PT	CR	5,229,872	07/1993	Mumola			
PT	DR	5,260,151	11/1993	Berger et al.			
PT	ER	5,296,891	03/1994	Vogt et al.			
PT	FR	5,523,193	06/1996	Nelson			
PT	GR	5,877,843	03/1999	Takagi et al.			
PT	HR	5,969,441	10/1999	Loopstra et al.			
PT	IR	6,046,792	04/2000	Van Der Werf et al.			
PT	JR	6,053,704	04/2000	Yamamoto et al.			
PT	KR	6,222,609	04/2001	Nishimura			
	LR						
	MR						
	NR						

FOREIGN PATENT DOCUMENTS

		Document Number	Date MM/YYYY	Country	Inventor Name	English Abstract		Translation Readily Available	
						Enclosed	No	Enclose	No
PT	OR	WO 98/40791	07/2001	Europe	Van der Schoot				
PT	PR	EP 0965888	12/1999	Europe	Bleeker				
PT	QR	0 532 968 A1	03/1993	Europe	Moriyama et al.				
PT	RR	0 844 532 A2	05/1998	Europe	Kamiya				
	SR								
	TR								
	UR								
	VR								
	WR								
	XR								

OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)

PT	YR	Murphy et al., "Synchrotron Radiation Sources and Condensers for Projection X-Ray Lithography," <i>Applied Optics</i> , Vol. 32, No. 24, 1993, pp. 6920-6929.			
	ZR				
	AAR				
	BBR				
	CCR				
	DDR				

Examiner

Date Considered: 9-7-04

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.